Abstract

This paper proposes a new 3D active transducer for sensing and measuring pressure and its direction using micromachined technology. The sensor used here depends on the variations of a parallel plate capacitor with one of the plates is tied while the other is tied from its ends only left to change shape under pressure waves directed in any direction. The capacitors are connected to the emitters of an EC multivibrator (ECMV) to change its frequency as capacitor value changes. The capacitor rods are arranged in parallel and the two sets are arranged at 90 degrees to each other to detect 2D variations in the measurands. The output of this transducer is an ECMV output which can be altered to any signal shape as required.

References

2. J. Eom, etc. 2015. Fiber optic fabry-perot pressure sensor based on lensed fiber and...
A New Proposed 3D Pressure Transducer


Index Terms

Computer Science  
Signal Processing

Keywords

Active sensors, Active transducers, nano-structures